

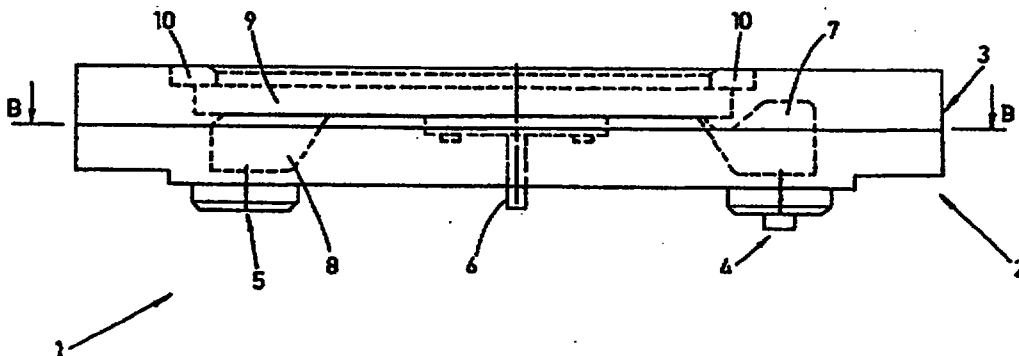
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(21) International Application Number: **PCT/IL96/00141**(22) International Filing Date: **4 November 1996 (04.11.96)**(30) Priority Data: **15934** **9 November 1995 (09.11.95)** **IL**(71) Applicant (for all designated States except US): **ORAMIR SEMICONDUCTOR EQUIPMENT LTD. (IL/IL); P.O.B. 14, 31000 Haifa (IL)**

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(57) Abstract

A process chamber for carrying out laser treatments, on the surface of an object, comprising: a base provided with object support means; a cover provided with a window substantially transmissive of laser light; gas inlet and gas outlet means; the said cover and the said base, when connected, leaving a space between the surface of the element and the inner surface of the window, in which gases flowing through the said gas inlet may flow above the surface of the object being treated and out of the process chamber through the said gas outlet.